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June 7, 2004

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Art Unit 2823

Commissioner for Patents PO Box 1450 Alexandria, VA 22313-1450

Re:

U.S. Utility Patent Application

Application No. 09/753,664; Filed: January 4, 2001

High Density Metal Capacitor Using Via Etched Stopping Layer as

Field Dielectric in Dual-Damascence Interconnect Process

Inventor: Our Ref:

Liming Tsau 1875.0230000

Sir:

Transmitted herewith for appropriate action are the following documents:

1. Letter to PTO Draftsman: Submission of Formal Drawings;

13 sheets of drawings: (Figures 1-15, 16A-16I, 17A-17I, 18A-18I and 2.

19A-19I); and

One (1) return postcard.

It is respectfully requested that the attached postcard be stamped with the date of filing of these documents, and that it be returned to our courier. In the event that extensions of time are necessary to prevent abandonment of this patent application, then such extensions of time are hereby petitioned.

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Commissioner for Patents June 7, 2004 Page 2

The U.S. Patent and Trademark Office is hereby authorized to charge any fee deficiency, or credit any overpayment, to our Deposit Account No. 19-0036.

Respectfully submitted,

STERNE, KESSLER, GOLDSTEIN & FOX P.L.L.C.

Jason D. Eisenberg Attorney for Applicant

Registration No. 43,447

JDE/lvt 273040\_1.DOC



## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

Liming Tsau

Appl. No.: 09/753,664

Filed: January 4, 2001

For: High Density Metal Capacitor

Using Via Etched Stopping Layer

as Field Dielectric in Dual-

**Damascence Interconnect Process** 

Confirmation No.: 1902

Art Unit: 2823

Examiner: K. Nguyen

Atty. Docket: 1875.0230000

Letter to PTO Draftsman: Submission of Formal Drawings

Commissioner for Patents PO Box 1450 Alexandria, VA 22313-1450

Sir:

Submitted herewith are thirteen sheets of formal drawings with Figures 1-15, 16A-16I, 17A-17I, 18A-18I and 19A-19I, corresponding to the informal drawings submitted with the above-captioned application. Identification of the drawings is provided in accordance with 37 C.F.R. § 1.84(c). Acknowledgment of the receipt, approval, and entry of these formal drawings into this application is respectfully requested.

It is not believed that an extension of time is required, other than any already provided herewith. However, if an extension of time is needed to prevent abandonment of the application, then such extension of time is hereby petitioned. The U.S. Patent and Trademark Office is hereby authorized to charge any fee deficiency, or credit any overpayment, to our Deposit Account No. 19-0036.

Respectfully submitted,

STERNE, KESSLER, GOLDSTEIN & FOX P.L.L.C.

Jason D. Eisenberg

Attorney for Applicant Registration No. 43,447

Date: June 7, 2004

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